

**TRANSMITTAL OF FORMAL DRAWINGS**Docket No.  
FIS920000149 (00750426AA)

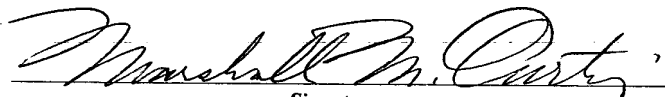
In Re Application Of: Ahlgren et al.

JUL 21 2003

Serial No.  
09/633,857Filing Date  
08/07/2000Confirmation No.  
3316Examiner  
R. KunemundArt Unit  
1765Invention: **IN-SITU MONITORING AND CONTROL OF GERMANIUM PROFILE IN SILICON-GERMANIUM ALLOY FILMS AND TEMPERATURE MONITORING DURING DEPOSITION OF SILICON FILMS**Address to:  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450RECEIVED  
JUL 23 2003  
GROUP 1700

Transmitted herewith are:

7 sheets of formal drawing(s) for this application.

☒ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

Signature

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30743

PATENT TRADEMARK OFFICE

Dated: July 21, 2003

I certify that this document and attached formal drawings are being deposited on \_\_\_\_\_ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

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